

Form PTO-1449 (Modified)  <b>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</b>  (Use several sheets if necessary)	Atty Docket No.	Serial No.
	HARAP0166US	10/556,663
	Applicant: Morito AKIYAMA, et al.	
	Filing Date	Group
	November 11, 2005	2811

## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date MM/YYYY	Name	Class	Sub-class	Filing Date if Appropriate

## FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date MM/YYYY	Country	Class	Sub-class	Translation	
						Yes	No
/DR/	00/76930	December 2000	WO				

## OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
/DR/	European Search Report for corresponding Application No. 04733100.4 dated March 19, 2007.
/DR/	Cheng H-E et al.; "Preparation of [002] oriented AIN thin films by mid frequency reactive sputtering technique"; Preparation and Characterization, Vol. 425, No. 1-2; pages 85-89; 2003.

EXAMINER     /Derek Rosenau/	DATE CONSIDERED     10/07/2008
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

**Information Disclosure Statement PTO-1449 (Modified)**

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.